

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Chen, et al.

Serial No.: 10/741,824

Confirmation No.: 2621

Filed: December 19, 2003

For: Enhancement of CU Line  
Reliability Using Thin ALD  
Tan Film to Cap the CU  
Line

Group Art Unit: 2823

Examiner: John M. Parker

## MAIL STOP RCE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

## CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to fax number 571-273-8300, or electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner John M. Parker, on the date shown below.

2/2/07  
Date

Kim R. R. R.  
Signature

### REQUEST FOR NON-ENTRY OF AMENDMENT

Applicants respectfully request non-entry of the Response filed on November 28, 2006, to the Final Office Action dated October 3, 2006. Applicants also respectfully request non-entry of the Response filed on December 21, 2006, to the Final Office Action dated October 3, 2006.

Respectfully submitted,

Kevin J. Zehr

Keith M. Tackett, Registration No. 32,008  
PATTERSON & SHERIDAN, L.L.P.  
3040 Post Oak Blvd. Suite 1500  
Houston, TX 77056  
Telephone: (713) 623-4844  
Facsimile: (713) 623-4846  
Attorney for Applicant(s)